

**Notice of References Cited**

Application/Control No.

10/029,144

Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.

Examiner

Mike Qi

Art Unit

2871

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,135,581	08-1992	Tran et al	136/256
	B	US-6,433,842	08-2002	Kaneko et al	349/43
	C	US-0029054	10-2001	Maeda et al	438/17
	D	US-6,225,150	05-2001	Lee et al	438/153
	E	US-0030717	10-2001	Kaneko et al	10-2001
	F	US-6,188,108	02-2001	Yoon et al	257/347
	G	US-0030723	10-2001	Koma	349/113
	H	US-0085142	07-2002	Kim et al	349/43
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.